



RECEIVED

JAN 06 2003

TC 1700

Attorney Docket SEL 238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)

Hiroki et al.)

Serial No.: 09/776,472)

Filed: February 2, 2001)

For: Thin Film Formation Apparatus And)
Method Of Manufacturing Self-Light-)
Emitting Device Using Thin Film)
Formation Apparatus)

Art Unit: 1762)

Examiner: M. Cleveland)

Commissioner for Patents
Washington, D.C. 20231

I hereby certify that this correspondence is being
deposited with the United States Postal Service as
first class mail in an envelope addressed to:

the Assistant Commissioner for Patents, Washington,
D.C. 20231 on December 26, 2002

(Date of Deposit)

Rachelle Hammerquist
Name of applicant, assignee, or Registered Rep.

Rachelle Hammerquist 12-26-02
Signature Date

AMENDMENT B

Sir:

In response to the Office Action of September 25, 2002, please amend the above-identified
application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

6 (Amended). A method of manufacturing a self-light-emitting device, comprising the steps

of:

filling a nozzle with an application liquid for forming an EL layer; and

BEST AVAILABLE COPY